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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :  
Takanobu TAKEDA et al. : Group Art Unit.: 1752

Serial No.: 10/085,935 : Examiner: LEE, Sin J.

Filed: March 1, 2002 :

Title: SILICON-CONTAINING POLYMER, RESIST COMPOSITION AND  
PATTERNING PROCESS

**REPLY**

Mail Stop: After Final  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SIR:

In response to the Office Action dated April 21, 2004, please amend the claims as follows and consider the remarks.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 15 of this paper.

**CERTIFICATION OF MAILING**

I hereby certify that this correspondence is being deposited with the U.S. Postal Services as First Class Mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on: July 21, 2004

Name:

Sharon McDaniel

Signature:

*Sharon McDaniel*  
MILLEN, WHITE, ZELANO & BRANIGAN, P.C.